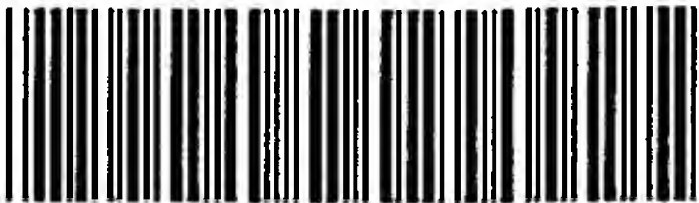


Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/604,820	CHI, CHAO-WEN	
	Examiner	Art Unit	
	Jeffrey Donels	2837	

SEARCHED			
Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
PLS Text PLUS	6/21/05	AD